
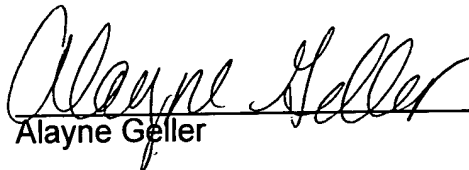


EAM 2812
7/A
B. Hines
12/8/00
Bao 9-1-13
4000-369US

The undersigned certifies that this communication is being deposited with the United States Postal Service as prepaid first class mail in an envelope addressed to the Assistant Commissioner for Patents, Washington, D.C. 20231 on November 22, 2000.



Alayne Geller

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of
Bao *et al.*

Serial No. 09/305,722

Filed: 05/05/1999

For: HIGH-RESOLUTION
METHOD FOR PATTERN-
ING A SUBSTRATE WITH
MICRO-PRINTING

Group Art Unit: 2812
Examiner: A. Alanko

Assistant Commissioner for Patents
Washington, D.C. 20231

SIR:

AMENDMENT

In response to the Office Action mailed August 23, 2000, please amend the above-identified application as follows:

IN THE CLAIMS

Amend claim 1:

AI Sub B1
1. (Amended) A method for forming at least one patterned layer on a substrate comprising the steps of: